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Application Number	TBA
Filing Date	January 6, 2005
First Named Inventor	Roy G. Gordon
Art Unit	TBA
Examiner Name	TBA
Attorney Docket Number	42697.147 US2

Sheet 1 of 1

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U. S. PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code ² (if known)			
		US-6,359,160 B1	03/19/2002	Sun et al.	
		US-2001/041250 A1	11/15/2001	Haukka et al.	
		US-2001/054730 A1	12/27/2001	Kim et al.	
		US-2001/002280 A1	05/31/2001	Sneh	

FOREIGN PATENT DOCUMENTS

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		Number-Kind Code ² (if known)			
		EP-1067595 A	01/10/2001	Air Prod & Chem	
		WO-01/27347 A	04/19/2001	ASM Microchemistry OY	
		WO-02/27063 A	04/04/2002	President and Fellows of Harvard College	

NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
		BECKER, J. S. et al., "DIFFUSION BARRIER PROPERTIES OF TUNGSTEN NITRIDE FILMS GROWN BY ATOMIC LAYER DEPOSITION FROM BIS (TERT-BUTYLIMIDO) BIS (DIMETHYLAMIDO) TUNGSTEN AND AMMONIA" Applied Physics Letters, American Institute of Physics, New York, US, vol. 82, no. 14, April 7, 2003, pages 2239-2241.	

Examiner Signature	/Shean Wu/	Date Considered	07/30/2008
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